



IPW
566.41191X00

1765
d

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Y. KURATA, et al.

Serial No: 10/049,672

Filed: APRIL 30, 2002

Title: POLISHING MEDIUM FOR CHEMICAL-MECHANICAL
POLISHING, AND METHOD OF POLISHING SUBSTRATE
MEMBER

Group AU: 1765

Examiner: Duy Vu Nguyen Deo

Confirm. No: 7706

PETITION FOR EXTENSION OF TIME

Mail Stop: AMENDMENT - FEE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

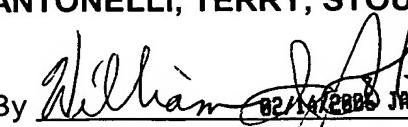
February 13, 2006

In the matter of the above-identified application, Applicants hereby respectfully petition for an extension of time to permit filing a response within the third month subsequent to expiration of the shortened statutory period set in the outstanding Office Action mailed August 11, 2005. A Credit Card Payment Form in the amount of \$1,020.00, for the requisite fee, is attached hereto.

Please charge any shortage in fees due to the Deposit Account of Antonelli, Terry, Stout & Kraus, LLP, account No. 01-2135 (case 566.41191X00), and credit any excess fees to such account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

By 
William I. Soloff, Esq. 80000075 10849672
Registration No. 28,565

WIS/vvr/ksh
1300 N. 17th St., Ste. 1800
Arlington, Virginia 22209
Tel: 703-312-6600
Fax: 703-312-6666